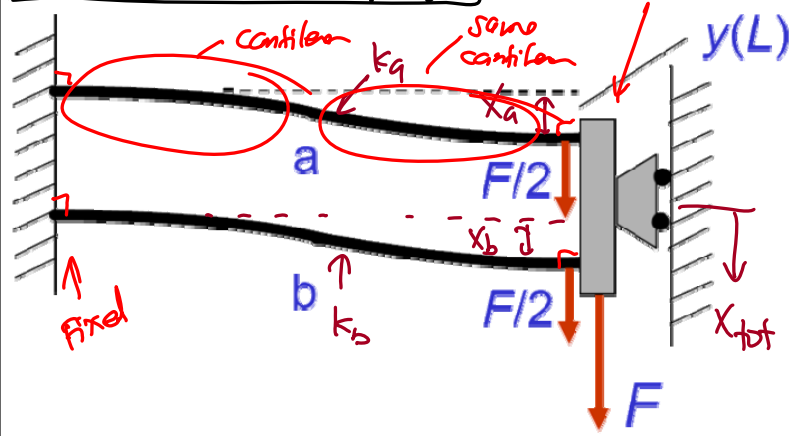


Lecture 16: Beam Combos I

- Announcements:
- This is our makeup lecture for Thursday next week
- Midterm is nearing: Thursday, Oct. 27
 - ↳ I will soon pass out materials associated with the midterm, including an information sheet and old exams
-
- Reading: Senturia, Chpt. 9
- Lecture Topics:
 - ↳ Bending of beams
 - ↳ Cantilever beam under small deflections
 - ↳ Combining cantilevers in series and parallel
 - ↳ Folded suspensions
 - ↳ Design implications of residual stress and stress gradients
-

Last Time:

Parallel Combination of Springs



Parallel: $x_{tot} = x_a = x_b$

$$y(L) = \frac{F}{k} = \frac{F_a}{k_a} = \frac{F_b}{k_b} = \left(\frac{F}{2}\right) \left(\frac{1}{k_a}\right)$$

↑
of the whole thing

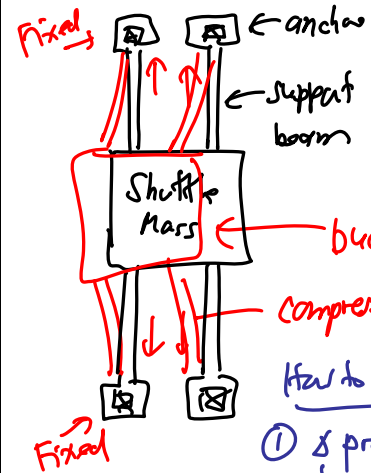
$k = 2k_a$

In general: $k_{tot} = k_a k_b$

For EEs: springs combine like capacitors

Folded-Beam Suspension

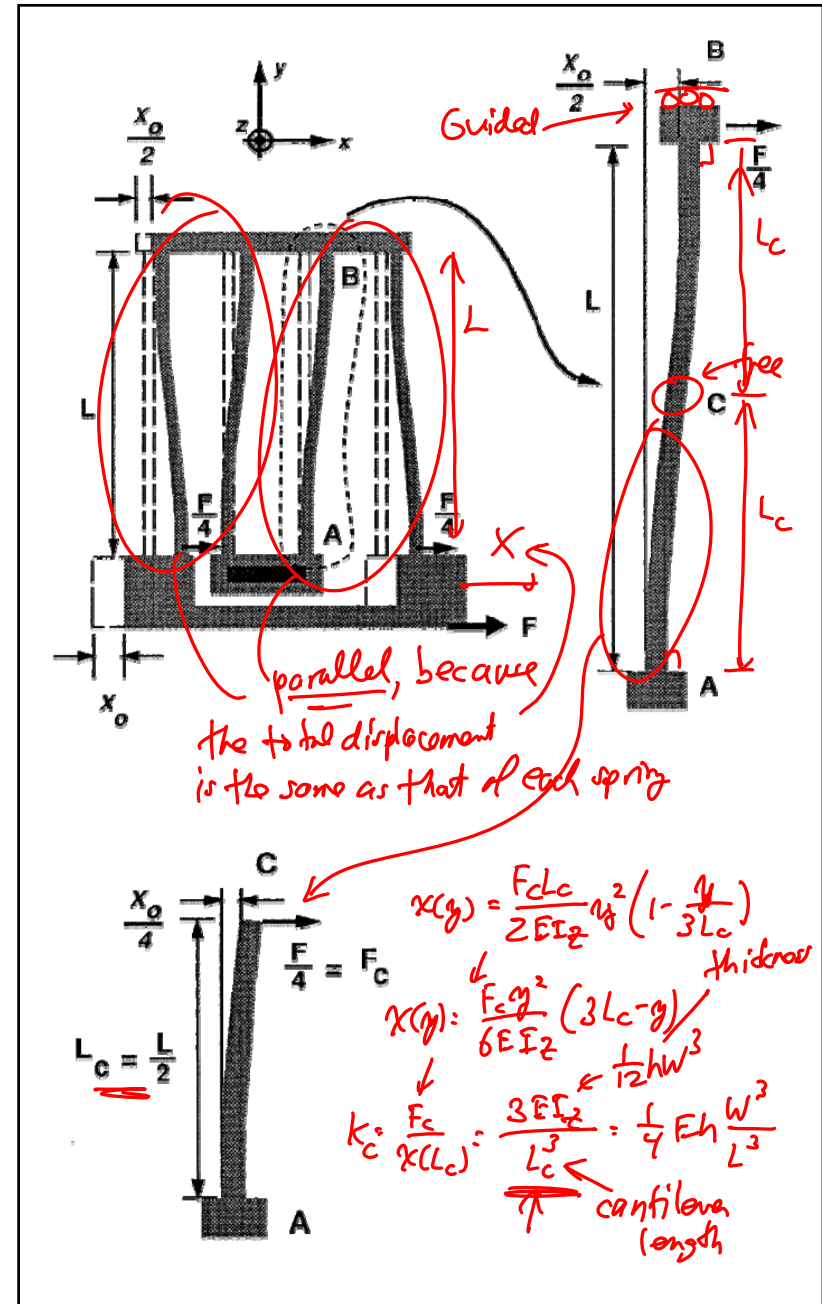
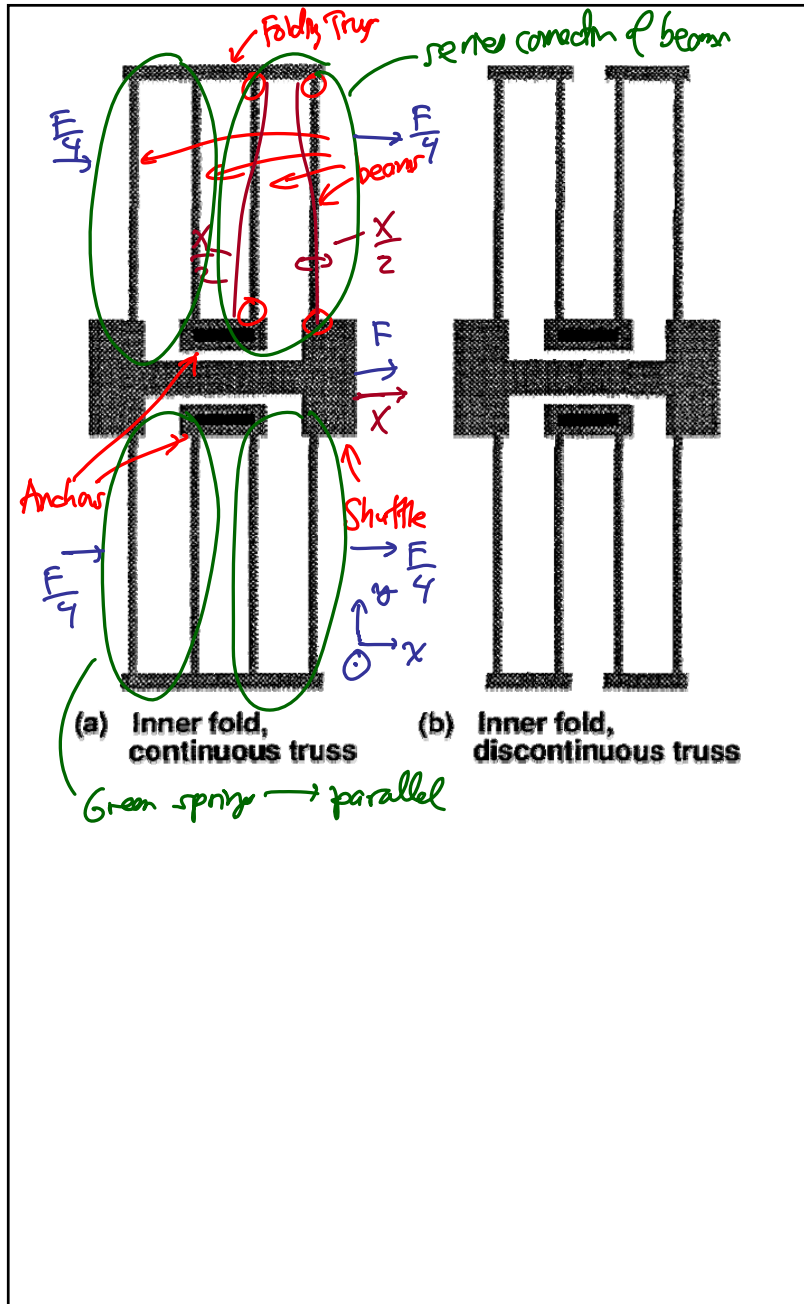
= Module P, Slide 22



- ① Dumb dep. @ high T → stress free
- ② Cool to RT → stress

How to Defend Against this:

- ① δ process parameters → deformation
↳ can't always do this
- ② Design → fold-beam!



\Rightarrow invert L_c

$$k_c = \frac{3EI_z}{(L/2)^3} = \frac{24EI_z}{L^3}$$

↑ stiffness of cantilever of length L_c ↑ full beam length

Pair of legs

leg

legs in series, because the total displacement X_{tot} equals the sum of the displacement of the individual legs

$F_{pair} = \frac{F}{4}$ ← applied to shuttle

$x = \frac{F_{pair}}{k_{pair}} = \frac{F_{pair}}{(k_{leg} || k_{leg})}$

$= \frac{F}{4} \left(\frac{1}{k_{leg}} + \frac{1}{k_{leg}} \right)$

From before: $k_{leg} || k_c || k_c = \frac{k_c}{2}$

Thus: $x = \left(\frac{F}{4} \right) \left(\frac{2}{k_c} + \frac{2}{k_c} \right) = \frac{F}{k_c} = \frac{F}{k_{tot}}$

$$k_{tot} = k_c = \frac{24EI_z}{L^3}$$

Both Way to Do It → Just consider stiffness

(a) Inner fold, continuous truss

(b) Inner fold, discontinuous truss

$k_c(4) = k_c = k_c$

Micromechanical Filter

Input Electrode, Suspension Beam, Coupling Beam, Output Electrode, Anchors, Shuttle, Folding Truss, Point A, Point B.

Dimensions: $200 \mu\text{m}$, $100 \mu\text{m}$, $2 \mu\text{m}$.

Masses: m_1 (shuttle), m_2 (shuttle).

Stiffnesses: k_c (coupling beam), k_{cs} (cantilever).

Handwritten notes:

- Find the stiffness of point A.
- (Shuttles are rigid)
- Supply F @ A \rightarrow what is x_A ?
- k_A = stiffness at point A
- $x_A = \frac{F}{k_A}$ ← want this
- $k_b = ? \rightarrow \frac{k_{cs}}{2}$

Get k_b :

Dimensions: $L = 200 \mu\text{m}$.

Stiffnesses: $k_{cs}/2$, k_{cs} , k_c .

Force: F .

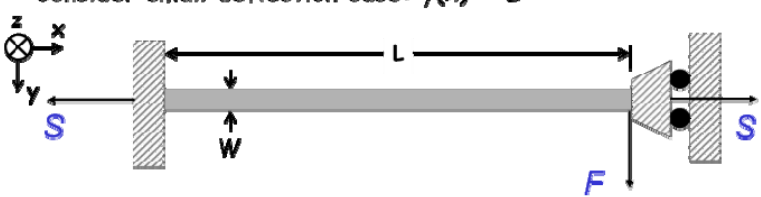
Displacement: x_A .

Handwritten notes:

- $\therefore k_A = k_c + k_{comb}$
- $k_A = k_c + k_{cs} \frac{k_c}{2}$ where $k_c = \frac{24EI_z}{L^3}$
- $k_{cs} = \frac{24EI_z}{L_{cs}^3}$

Tensioned Spring (Non-Ideality)

- Important case for MEMS suspensions, since the thin films comprising them are often under residual stress
- Consider small deflection case: $y(x) \ll L$



Governing differential equation: (Euler Beam Equation)

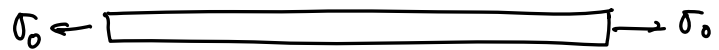
$$EI_z \frac{d^4 y}{dx^4} + S \frac{d^2 y}{dx^2} = F \delta(x-L)$$

Axial Load
Unit Impulse @ $x=L$

Heuristic Derivation for the Euler Beam Equation

Consider first a straight beam under an axial stress:

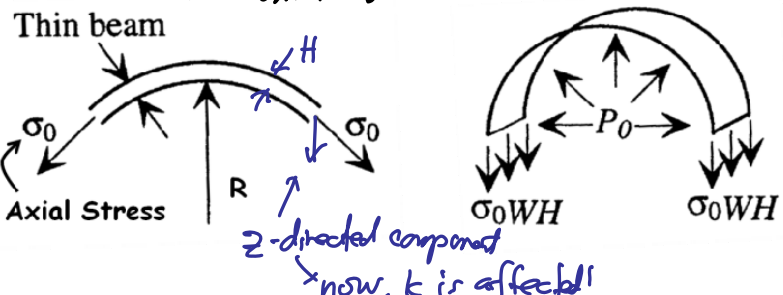
$\downarrow z$



\Rightarrow no effect on z-directed stiffness when the beam is straight

...but when the beam is bent:

Thin beam



z-directed component
 \rightarrow now, k is affected!